

Electronic Acknowledgement Receipt

EFS ID:	1326696
Application Number:	10537211
International Application Number:	
Confirmation Number:	1865
Title of Invention:	Production of microelectromechanical systems (mems) using the high-temperature silicon fusion bonding of wafers
First Named Inventor/Applicant Name:	Uwe Schwarz
Customer Number:	8933
Filer:	Stephan P. Gribok
Filer Authorized By:	
Attorney Docket Number:	D4695-00135
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Application Type:	U.S. National Stage under 35 USC 371

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Power of Attorney	D4695-135-POA.pdf	139247	no	1

Warnings:

Information:	Total Files Size (in bytes):	139247
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<u>New Applications Under 35 U.S.C. 111</u>		
If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.		
<u>National Stage of an International Application under 35 U.S.C. 371</u>		
If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.		